

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

	Papa Rao et al.	Examiner: TBD
Serial No:	TBD	Art Unit: TBD
Filed:	10/05/00	Docket No.: TI-29098
For:	X-RAY DEFECT DETECTION IN INTEGRATED CIRCUIT METALLIZATION	

PRELIMINARY AMENDMENT

October 5, 2000

Assistant Commissioner for Patents

Washington, DC 20231

Dear Sir:

Please amend the above referenced application as follows:

In the Specification:

Page 1, before line 1, insert - This application claims priority under 35 USC §

119(e)(1) of provisional application numbers 60/168,204 filed 11/30/99.--